11-22-02

Attorney Docket No.: LAM1P126/P0562

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TIFICATE OF EXPRESS MAILING I have yearlighted this paper and the documents and/or fees referred to as attached therein are being deposited with the United States Postal Service on November 20, 2002 in an envelope as "Express Mail Post Office to Addressee" service under 37 CFR §1.10, Mailing Label Number EL898680810US, addressed to: Box CPA, Commissioner for Patents, Washington, D.C. 20231.

First Named Inventor: BAILEY

(Revised 11/00, Pat App Trans Rule 53(d) CPA)

CONTINUED PROSECUTION APPLICATION (CPA) REQUEST TRANSMITTAL **UNDER 37 CFR §1.53(d)**

	Box CPA Commissioner for Patents Washington, D.C. 20231 This is a request for filing a Continuation Divisional	RECEIVED NOV 2 5 2002 TC 1700						
	application under 37 CFR §1.53(d) (continued prosecution application) of prior pending application No. 09/536,347, filed on March 27, 2000, entitled METHOD AND APPARATUS FOR PLASMA FORMING INNER MAGNETIC BUCKET TO CONTROL A VOLUME OF A PLASMA.							
	Assigned to: Lam Research Corporation							
	 □ Do not publish this application. Nonpublication Request is attached. □ Enter the unentered amendment previously filed on under 37 CFR the prior nonprovisional application. ☑ A preliminary amendment is enclosed. □ This application is filed by fewer than all the inventors named in the prior 1.53(d)(4). DELETE the following inventor(s) named in the prior response. 	r application, 37 CFR						
	A new power of attorney or authorization of agent (PTO/SB/81) is enclosed. Information Disclosure Statement with Form PTO-Form 1449 is enclosed.							
11/	Copies of IDS Citations 25/2002 NH0HAMM1 00000137 09536347							
	FC:1006 740.00 OP							

Page 1 of 2

Fee Calculation (37 CFR § 1.16)

Applicant is entitled to Small Entity Status under 37 C.F.R. § 1.27.

	(Col. 1) Total Claims		(Col. 2) Claims	(Col. 3) Present Extra	Poto	Additional Foo
					Rate	Additional Fee
TOTAL	20	MINUS	20	= 0	x 18 =	\$-0-
INDEP.	2	MINUS	3	= 0	x 84 =	\$-0-
	\$740.00					
	\$740.00					

The Commissioner is hereby authorized to credit overpayments or to charge any fees due to Deposit Account No. 50-0388 (Order No. LAM1P126).

General Authorization for Petition for Extension of Time (37 CFR §1.136)

Applicants hereby make and generally authorize any Petitions for Extensions of Time as may be needed for any subsequent filings. The Commissioner is also authorized to charge any extension fees under 37 CFR §1.17 as may be needed to Deposit Account No. 50-0388 (Order No. LAM1P126).

Check No. 2203 in the amount of \$740.00 is enclosed in payment of filing fee.

Suspension of Prosecution for the time necessary to file an amendment is requested.

An Extension of Time in the prior application is requested.

A Conditional Extension of Time in the prior application is requested.

Other:

Please continue to send correspondence to the following address:

Customer Number 022434

22434
PATENT AND TRADEMARK OFFICE

Date: November 20, 2002

Michael Lee

Registration No. 31,846



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: BAILEY

Application No.: 09/536,347

Filed: March 27, 2000

Title: METHOD AND APPARATUS FOR PLASMA FORMING INNER MAGNETIC BUCKET TO CONTROL A VOLUME OF A

PLASMA

Attorney Docket No.: LAM1P126/P0562

Examiner: ALEJANDRO MULERO,

Luz L.

Group: 1763

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AMENDMENT C

Box CPA Commissioner for Patents Washington, D.C. 20231

Dear Sir:

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TC 1700

In response to the Office Action dated September 23, 2002, please amend the above-identified patent application as follows:

In the Claims

Please cancel claim 8.

Please amend claims 2 and 17, as follows:

2. (Twice Amended) A plasma processing apparatus for processing a substrate, comprising: a process chamber, comprising:

a wall defining part of the process chamber;